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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT
PTO-1449**

DOCKET NO. 10020/22301	SERIAL NO. 10200 MAIL ROOM
APPLICANT FORREST et al.	
FILING DATE April 13, 2001	GROUP

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE*
TP	5,641,611	June 24, 1997	Shieh et al.			
	5,707,745	January 13, 1998	Forrest et al.			
	5,925,259	July 20, 1999	Biebuyck et al.			
	5,998,803	December 7, 1999	Forrest et al.			
	6,013,538	January 11, 2000	Burrows et al.			
	6,027,630	February 22, 2000	Cohen			
	6,214,631	April 10, 2001	Burrows et al.			

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
TP	96/19792	June 27, 1996	WO			X	
TP	98/28946	July 2, 1998	WO			X	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
TP	Kim et al., "Micropatterning of Organic Electronic Devices by Cold-Welding", <u>Science</u> , Vol. 288, pp. 831-833, 5 May 2000
	Stutzmann, et al., "Patterning of polymer-supported metal films by microcutting", <u>Nature</u> , Vol 407, pp. 613-616, 5 October 2000.
	P.W.M. Blom et al., "Efficiency and stability of polymer light-emitting diodes", <u>Journals of Materials Science Materials in Electronics</u> , Volume 11, Number 2, March 2000, pp. 105-109.

EXAMINER	DATE CONSIDERED
<i>T. P.</i> 3/10/04	

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form 1449	ATTY. DOCKET NO. 10020/22301	SERIAL NO. 09/833,695
INFORMATION DISCLOSURE STATEMENT BY APPLICANT	APPLICANT Stephen R. FORREST, et al.	
	FILING DATE April 13, 2001	GROUP 2812

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U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION
					<input checked="" type="checkbox"/> YES

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.	
<i>TP</i>	Y. XIA, et al., <i>Unconventional Methods for Fabricating and Patterning Nanostructures</i> , Chem. Rev. 99:7, pp. 1823-1848 (1999)	
EXAMINER	<i>T. P</i>	DATE CONSIDERED
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